

# Multicrystalline Silicon Passivation by Hydrogen and Oxygen-Rich Porous Silicon Layer for Photovoltaic Cells Applications

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**Abstract:** In this work, we demonstrate the beneficial effect of introducing a superficial porous silicon layer on the electronic quality of multi-crystalline silicon for photovoltaic cell application. The porous silicon was prepared using an acid vapor etching-based method. The porous silicon layer rich in hydrogen and oxygen formed by vapor etching using an excellent passivating agent for the mc-Si surface. Laser beam-induced current (LBIC) analysis of the exponent parameter ( $n$ ) and surface current mapping demonstrated that oxygen and hydrogen-rich porous silicon led to an excellent surface passivation with a strong electronic quality improvement of multi-crystalline silicon. It was found that the generated current of treated silicon by acid vapor etching-based method is 20 times greater than the reference substrate, owing to recombination centers passivation of the grains and grain boundaries (GBs); The actual study revealed an apparent decrease in the recombination velocity of the minority carrier as reflected by 25% decrease in the exponent parameter ( $n$ ) of the LBIC versus  $X$ -position measurements. The results obtained for the prepared porous silicon in this study indicates its possible use in a more efficient photovoltaic cell applications.

**Keywords:** Multi crystalline silicon, Laser beam induced current, Vapor etching, Oxygen and hydrogen, Passivation.

## 1. INTRODUCTION

Technological advances have recently improved efficiencies in multi-crystalline silicon (mc-Si) photovoltaic cells, making them a popular choice for solar panel manufacturers. Mc-Si is a very attractive material due to its low wafer cost compared to monocrystalline silicon (c-Si) [1, 2]. The random orientation of crystals in mc-Si can lead to defects and impurities, reducing the efficiency of solar cells made from this material. In addition, the grain boundaries between the individual crystals can act as recombination centers for charge carriers, reducing the cell's overall efficiency. They can be improved by utilizing oxygen and hydrogen passivation of crystal defects [3-5]. Compared to monocrystalline silicon (c-Si), which has a higher efficiency due to its single, continuous crystal structure, mc-Si typically has a lower efficiency. However, mc-Si is also less expensive to produce than c-Si, which makes it a more cost-effective option for many solar panel manufacturers. Additionally, ongoing research and development in the field of mc-Si technology may lead to further improvements in efficiency and performance in the future [6, 7]. Previous research has shown that mc-Si passivation using

oxygen and hydrogen-rich porous silicon can improve its electronic quality and enhance the efficiency of photovoltaic cells made from this material [8, 9].

This study aims to investigate the effectiveness of a superficial porous silicon layer formed using an Acid Vapor Etching-based method for passivating the mc-Si surface. This method has advantages over other techniques due to its low cost, simplicity, and compatibility with industrial processes. To assess the quality of the passivation layer, we carried out various characterization techniques, including Laser Beam-Induced Current (LBIC) analysis, IR reflectivity, absorption, and two-dimensional internal quantum efficiency measurements. These techniques allow us to determine the effect of the oxygen and hydrogen-rich porous silicon on the optoelectronic quality of the mc-Si and the reduction in recombination centers for charge carriers at the grain boundaries. The results of our study have implications for the development of more efficient and cost-effective photovoltaic cells.

## 2. MATERIALS PROCEDURES

P-type mc-Si wafers with a resistivity 0.5-2  $\Omega$ .cm



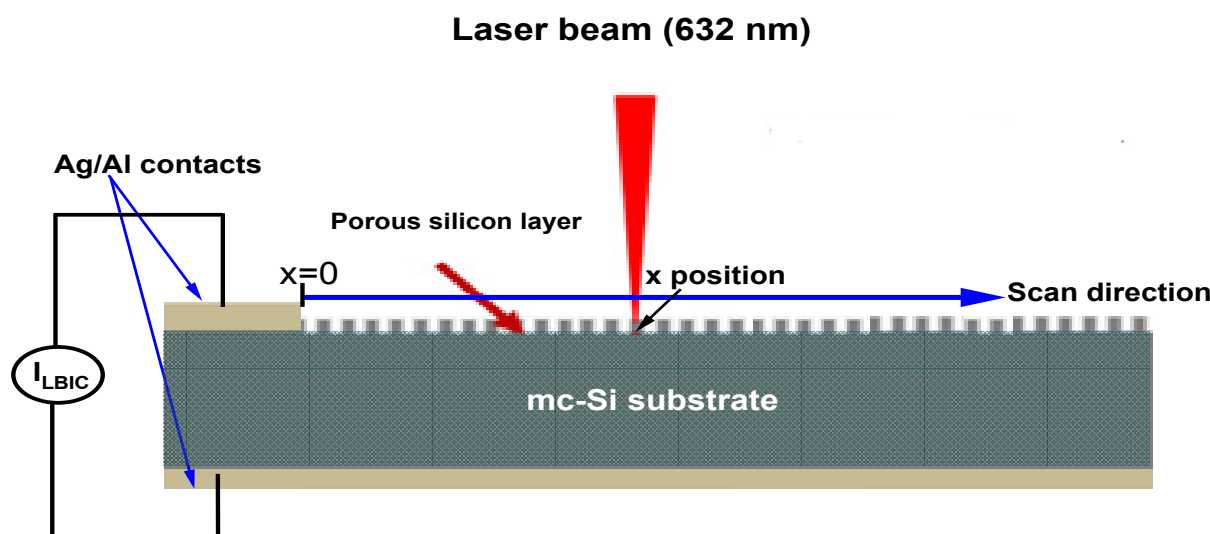


Fig. 2. LBIC technique to measure current by scanning mc-Si surface

Table 1. Exponent parameter (n) estimates for untreated and treated samples by AVE

Fit Model $f(x) = B * x^{-n}$	B	95% confidence bounds	n	95% confidence bounds	R <sup>2</sup>
Untreated	138.4	(115.8, 160.9)	0.9684	(0.9476, 0.9891)	0.9747
Treated	29.2	(23.32, 35.08)	0.728	(0.7026, 0.7533)	0.931

The obtained results of Exponent parameter (n) for untreated 0.97 and treated 0.73 samples indicate a significant improvement in the purity of the silicon after treatment due to the reduction of the surface recombination velocity and to the electronic quality improvement.

Figure 4 displays the FTIR spectra obtained after forming porous silicon by AVE, which reveal two influential bands. The first absorption peak, observed at wave numbers 1025-1160 cm<sup>-1</sup>, is attributed to oxygen complexes, specifically Si-O stretching modes in O-Si-O and c-Si-O. The second band, present at wave numbers 2050-2260 cm<sup>-1</sup>, is attributed to Si-H stretching modes of Si-H<sub>x</sub>, where x = 1, 2, and 3. As per reference, the absorption peaks observed at wave number 1427 cm<sup>-1</sup> can be assigned to the N-H bonding group [14]. It is also worth noting that the XPS spectra contribute to the FTIR spectrum, as mentioned in [15, 16]. Based on the FTIR spectra presented in Figure 4, samples with higher concentrations of O and H exhibit both bands specific to hydrogen and oxygen-related complexes (see Table 2).

The efficacy of hydrogen and oxygen passivation of mc-Si silicon wafers has been confirmed to decrease surface recombination velocity and enhance electronic quality significantly. This is crucial in diminishing non-radiative Si dangling

bond defects. After AVE treatment, the exponentiation (n) decreases by a whopping 25 % from 0.97 to 0.73, indicating the exceptional electronic quality of the mc-Si substrate. These findings unequivocally demonstrate the high efficiency of the passivation process in improving the substrate's electronic properties [17].

In the IR absorption spectrum, the integrated intensity of hydrogen and oxygen, were deduced by the relation 2 [18]:

$$I = \frac{N}{A} = \int \alpha(\omega)/\omega d\omega \quad (2)$$

N, A, ω and α in the above equation are, respectively, the concentration, the proportionality constant, the wave number and the absorption coefficient. In figure 5, we give the two-dimensional Internal Quantum Efficiency (IQE) distribution figure .5a before and figure .5b after PS treatment using the LBIC technique.

One may notice that the IQE varies between 25% and 35% for mc-Si wafers without PS. However, after PS treatment, the minimum value of the IQE of the mc-Si wafer becomes 55%, and the maximum value reached 65% (which represents an increase of about 30%). Recorded to [19], two-dimensional Generated Current I<sub>LBIC</sub> distribution before AVE and after AVE were illustrated in Figure 5.

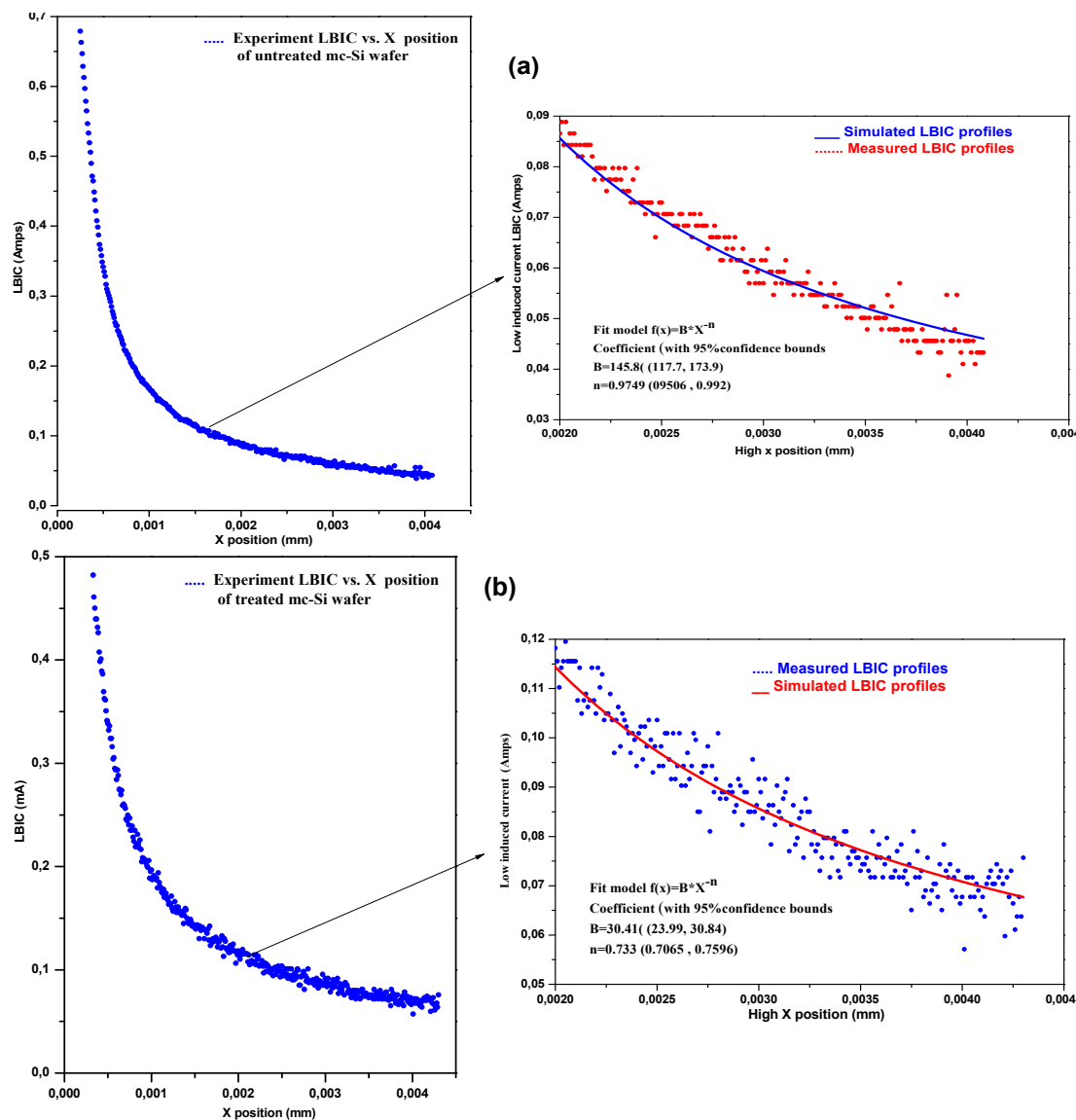


Fig. 3. a) LBIC profiles for untreated mc-Si b) AVE-treated mc-Si. Full lines correspond to theoretical simulation.

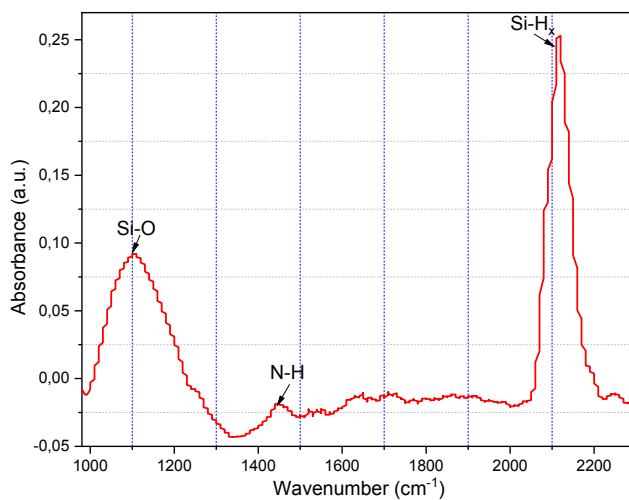
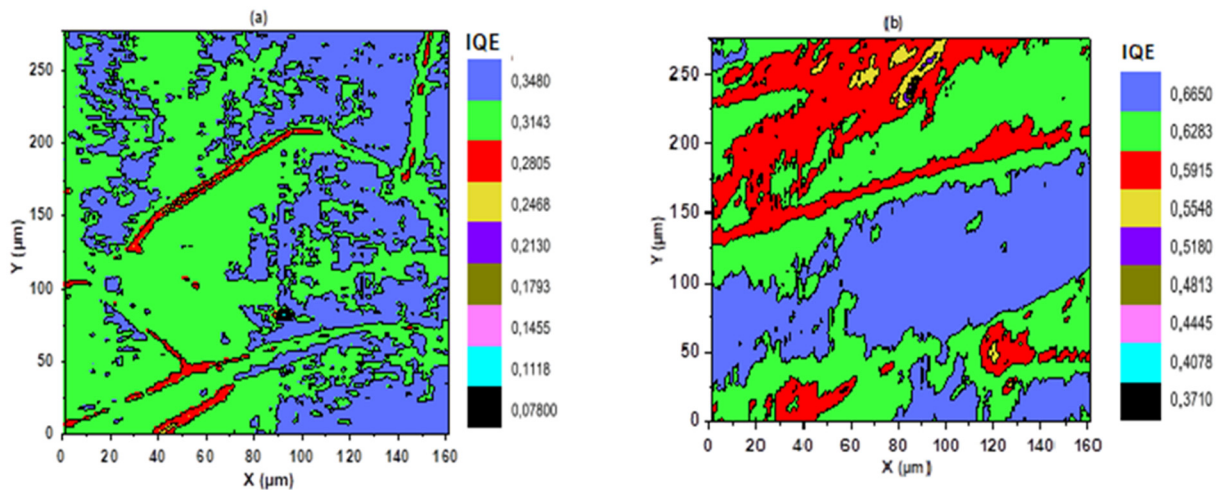


Fig. 4. FTIR spectra after porous silicon formation (spectra of the untreated sample as a reference)

**Table 2.** Oxygen and hydrogen integrated intensity from FTIR spectrum before and after mc-Si AVE

mc-Si	Integrated intensity of oxygen in $\text{cm}^{-1}$	Integrated intensity of hydrogen in $\text{cm}^{-1}$
Before	0	0
After	0.008	0.012

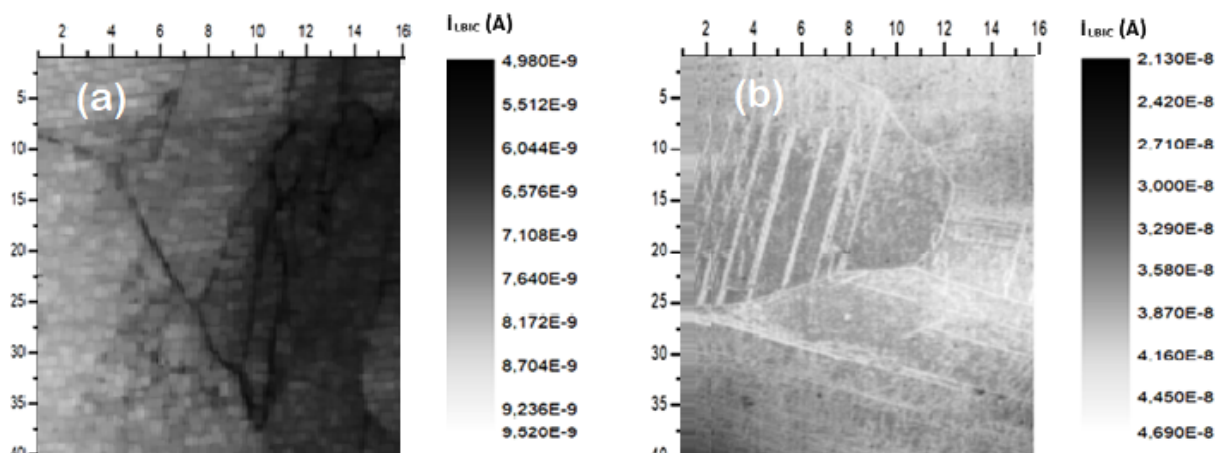


**Fig. 5.** a) Two-dimensional IQE distribution before PS b) after treatment using the LBIC technique

A significant variation in the Generate Current due to variations in the defects' density has been detected. Moreover, an enhancement of the  $I_{LBIC}$  after AVE was observed compared to untreated mc-Si; in this case, the measured  $I_{LBIC}$  varied between 21 nA to 47 nA (figure 6b), while the Generate Current varied between 4.98 nA to 9.52 nA for untreated mc-Si (figure .6a), this progression in the measured current  $I_{LBIC}$  can be explained by the reduction of the surface recombination velocity and to the electronic quality improvement due to recombination centers passivation at the grains and GBs.

Indeed, the disappearance of the dark areas in both grain and grain boundaries of mc-Si has been observed. Therefore, this disappearance can be ascribed to the diminution of defects' density as a consequence of the hydrogen and oxygen passivation effect [20-24].

A significant decrease in reflectivity was observed in figure 7 and reached 3% after AVE, compared to 38% for untreated mc-Si, the result of the change in the mc-Si surface morphology and its similar to silicon nanowire's structure [20], it has a direct effect of the minority carrier diffusion length [21].



**Fig. 6.** a) Two-dimensional Generated Current ILBIC distribution before AVE max value 9.5 10-9 A b) after AVE max value 46.9 10-9 A.

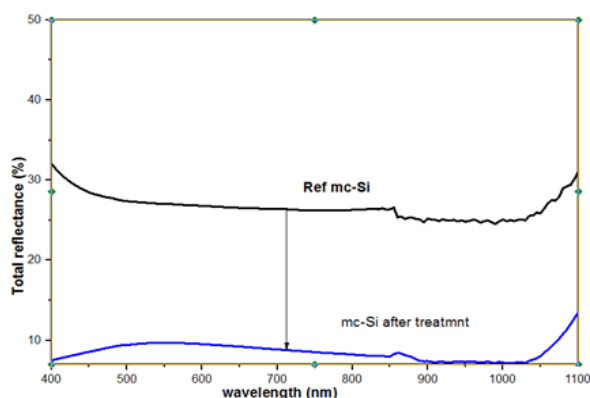


Fig. 7. Total reflectivity of mc-Si surface before and after AVE

#### 4. CONCLUSIONS

The study utilized Acid Vapor Etching to create oxygen and hydrogen-related compounds to improve the surface passivation and electronic properties of multi-crystalline silicon wafers. The results demonstrated substantial improvements in Generated Current mapping, surface recombination velocity, and IQE measured by laser beam-induced current. The presence of these compounds in silicon led to a 30% increase in IQE and a 25% decrease in the exponent parameter ( $n$ ), indicating a reduction in recombination velocity. This research has important implications for developing more efficient and cost-effective solar technologies and future photovoltaic cells. The findings provide insights into the effectiveness of Acid Vapor Etching in improving the electronic properties of multi-crystalline silicon wafers. They can help pave the way for further research in this area. Overall, this study represents a significant step forward in the field of solar cell technology and has the potential to contribute in creating more sustainable and environmentally friendly energy sources.

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#### REFERENCES

[1] Ballif, C., Haug, F. J., Boccard, M., Verlinden, P. J., Hahn, G. "Status and

perspectives of crystalline silicon photovoltaics in research and industry". *Nat Rev Mater*, 2022, 7, 597–616.

[2] Abdouli, B., Khezami, L., Guesmi, A., Assadi, A. A., Rabha, M. B. "Numerical and Experimental Study of the Front Surface Recombination Velocities and Base Widths Effect in Multi-Crystalline Silicon Solar Cell Quantum Efficiency". *Crystals*, 2023, 13(3), 425.

[3] Strehlke, S., Bastide, S., Lévy-Clément, C. "Optimization of porous silicon reflectance for silicon photovoltaic cells". *Solar Energy Materials and Solar Cells*, 1999, 58, 399.

[4] Bilyalov, R.R., Lüdermann, R., Wettling, W., Stalmans, L., Poortmans, J., Nijs, J., Schirone, L., Sotgiu, G., Strehlke, S., Lévy-Clément, C. "Multicrystalline silicon solar cells with porous silicon emitter". *Solar Energy Materials and Solar Cells*, 2000, 60, 391.

[5] Saadoun, M., Mliki, N., Kaabi, H., Daoudi, K., Bessaïs, B., Ezzaouia, H., Bennaceur, R. "Vapour-etching-based porous silicon: A new approach". *Thin Solid Films*, 2002, 405, 29.

[6] Muduli, S. P., Kale, P. "State-of-the-art passivation strategies of c-Si for photovoltaic applications". *A review. Mater. Sci. Semicond. Process*, 2023, 154, 107202.

[7] Ling raja, D., Kumar, S. P., Ram, G. D., Ramya, S. "Experimental Investigation of Influence of Electrolytic Solution in Porous Silicon Formation for Solar Energy Conversion". *Silicon*, 2023, 1-8.

[8] Rabha, M. B., Khezami, L., Jemai, A. B., Alhathloul, R., Ajbar, A. "Surface passivation of silicon nanowires based metal nano-particle assisted chemical etching for photovoltaic applications". *Journal of Crystal Growth*, 2017, 462, 35-40.

[9] Achref, M., Khezami, L., Mokraoui, S., Rabha, M. B. "Effective surface passivation on multicrystalline silicon using aluminum/porous silicon nanostructures". *Surfaces and Interfaces*, 2020, 18, 100391.

[10] Rabha, M. B., Boujmil, M. F., Saadoun, M., Bessaïs, B. "The use of chemical vapor etching in multicrystalline silicon solar

- cells". The European Physical Journal-Applied Physics, 2009, 47(1).
- [11] Davidson, S.M., Dimitriadis, C.A. "Advances in the electrical assessment of semiconductors using the scanning electron microscope". Microscopy J, 1980, 118, 275.
- [12] Sayad, Y., Kaminski, A., Blanc, D., Nouiri, A., Lemiti, M. "Determination of diffusion length in photovoltaic crystalline silicon by modelisation of light beam induced current". Superlattices and Microstructures, 2009, 45(4-5), 393-401.
- [13] Bisi, O., Ossicini, S., Pavese, L. "Porous silicon: a quantum sponge structure for silicon based optoelectronics". Surf. Sci. Rep, 2000, 38, 1-126.
- [14] Bahari, A., Morgen, P., Li, Z. S. "Growth of ultrathin silicon nitride films on Si (111)". Physical Review B, 2006, 24(4), 2119-2123.
- [15] Hashemi, A., Bahari, A. "Synthesis and characterization of silanized-SiO<sub>2</sub>/povidone nanocomposite as a gate insulator: The influence of Si semiconductor film type on the interface traps by deconvolution of Si2s". Current Applied Physics, 2018, 18(12), 1546-1552.
- [16] Bahari, A., Ghovati, M., Hashemi, A. "Studying of SiO<sub>2</sub>/capron nanocomposite as a gate dielectric film for improved threshold voltage". Applied Physics A, 2019, 125, 1-7.
- [17] Khezami, L., Jemai, A. B., Alhathloul, R., Rabha, M. B. "Electronic quality improvement of crystalline silicon by stain etching-based PS nanostructures for solar cells application". Solar Energy, 2016, 129, 38-44.
- [18] Zanzucchi, P.J. "The vibrational spectra of a-Si:H". In: Willardson, R.K., Beer, A.C. (Eds.), In: Semiconductors and Semimetals, vol. 21b. Academic Press, New York, 1984, p. 135.
- [19] Benrabha, M., Mohamed, S.B., Dimassi, W., Gaidi, M., Ezzaouia, H., Bessais, B. "Optoelectronic enhancement of monocrystalline silicon solar cells by porous silicon-assisted mechanical grooving". Physica status solidi c, 2011, 8, 887-890.
- [20] Benrabha, M., Dimassi, W., Bouaicha, M., Ezzaouia, H., Bessais, B. "Laser-beam-induced current mapping evaluation of porous silicon-based passivation in polycrystalline silicon solar cells". Sol. Energy, 2009, 83, 721.
- [21] Nafie, N., Lachiheb, M.A., Benrabha, M., Dimassi, W., Bouaicha, M. "Effect of the doping concentration on the properties of silicon nanowires". Physica E: Low-dimensional Systems and Nanostructures, 2014, 56, 427-430.
- [22] Benrabha, M., Bessais, B. "Enhancement of photovoltaic properties of multi crystalline silicon solar cells by combination of buried metallic contacts and thin porous silicon". Solar Energy, 2010, 84, 486-491.
- [23] Khezami, L., AlMegbel, A.O., Jemai, A.B., Ben Rabha, M. "Theoretical and experimental analysis on effect of porous silicon surface treatment in multicrystalline silicon solar cells". Applied Surface Science, 2015, 353, 106-111.
- [24] Zhou, J., Su, X., Huang, Q., Zhang, B., Yang, J., Zhao, Y., Hou, G. "Recent advancements in Poly-Si/SiO<sub>x</sub> passivating contacts for high-efficiency silicon solar cells: technology review and perspectives". J. Mater. Chem. A, 2022, 10, 20147-20173.